

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Yukio TAKIGAWA et al.**

Serial No.: **Not yet assigned**

Filed: **April 5, 2004**

For: **METHOD FOR FABRICATING SEMICONDUCTOR DEVICE**

Attorney Docket No.: **042323**

Customer Number: **38834**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 5, 2004

Sir:

Prior to calculation of the filing fee and examination of this application, please amend the above-identified application as follows:

Remarks begin on page 3 of this paper.